EXPEDITED PROCEDURE – Art Unit 2811

Attorney Docket No. 108298737US

Disclosure No. 03-0675.00/US

Amendments to the Claims:

Please amend claims 14-25, and cancel claim 13. Following is a complete listing of the claims pending in the application, as amended:

1. (Previously presented) A method for processing a microelectronic device, comprising:

fabricating a plurality of dies at an active side of a microelectronic workpiece, the dies having integrated circuitry and bond-pads coupled to the integrated circuitry;

constructing a redistribution assembly at the active side of the workpiece before separating the dies by depositing a dielectric layer over the dies and forming conductive elements having traces connected to corresponding bond-pads on the dies and ball-pads arranged in ball-pad arrays;

covering a backside of the workpiece with a protective material in a flowable state before separating the dies; and

curing the protective material to create a protective layer on the backside of the workpiece.

- 2. (Original) The method of claim 1, further comprising: attaching a plurality of solder balls to the ball-pads; and covering the dielectric layer with an active side protective film that surrounds at least a portion of the solder balls.
- 3. (Original) The method of claim 1 wherein covering the backside of the workpiece comprises stencil printing the material onto the backside of the workpiece.
- 4. (Original) The method of claim 1 wherein covering the backside of the workpiece comprises spraying the material onto the backside of the workpiece.
- 5. The method of claim 1 wherein covering the backside of the workpiece comprises spin coating the material onto the backside of the workpiece.

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6. (Original) The method of claim 1 wherein covering the backside of the

workpiece comprises applying the material onto the backside of the workpiece in a dip bath.

7. (Original) The method of claim 1 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 50°C to 500°C for

approximately 15-150 minutes.

8. (Original) The method of claim 1 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 150°C to 250°C for

approximately 15-120 minutes.

9. (Original) The method of claim 1 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 150°C for approximately 120

minutes.

10. (Original) The method of claim 1 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 200°C for approximately 15

minutes.

11. (Original) The method of claim 1 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 250°C for approximately 60

minutes.

12. (Original) The method of claim 1 wherein the material is a polyimide, epoxy-

based, and/or modified silicone material.

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13. (Cancelled)

14. (Currently amended) A method for protecting a microelectronic device, the method comprising: The method of claim 13, further comprising:

providing a microelectronic workpiece having an active side, a backside, and a plurality of dies at the active side of the workpiece, wherein the dies include integrated circuitry and bond-pads coupled to the integrated circuitry;

providing a redistribution assembly at the active side of the workpiece, the redistribution assembly having a dielectric layer over the dies, ball-pads arranged in ball-pad arrays corresponding to the dies, and traces coupling the bond-pads of a die to the ball-pads of a corresponding ball-pad array;

covering the backside of the workpiece with a coating of protective material in a flowable state before separating the dies;

changing the protective material to a non-flowable state;

attaching a plurality of solder balls to the ball-pads; and

covering the dielectric layer with a protective film that surrounds at least a portion of the solder balls.

- 15. (Currently amended) The method of claim 13-14 wherein covering the backside of the workpiece comprises stencil printing the material onto the backside of the workpiece.
- 16. (Currently amended) The method of claim 13-14 wherein covering the backside of the workpiece comprises spraying the material onto the backside of the workpiece.
- 17. (Currently amended) The method of claim 13-14 wherein covering the backside of the workpiece comprises spin coating the material onto the backside of the workpiece.
- 18. (Currently amended) The method of claim 13-14 wherein covering the backside of the workpiece comprises applying the material onto the backside of the workpiece in a dip bath.

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19. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material by heating the material in an

environment at a temperature of approximately 50°C to 500°C for approximately 15-150

minutes.

20. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material by heating the material in an

environment at a temperature of approximately 150°C to 250°C for approximately 15-120

minutes.

21. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material by heating the material in an

environment at a temperature of approximately 150°C for approximately 120 minutes.

22. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material by heating the material in an

environment at a temperature of approximately 200°C for approximately 15 minutes.

23. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material by heating the material in an

environment at a temperature of approximately 250°C for approximately 60 minutes.

24. (Currently amended) The method of claim 13-14 wherein changing the protective

material to a non-flowable state comprises curing the material using rapid thermal processing.

25. (Currently amended) The method of claim 13-14 wherein the material is a

polyimide, epoxy-based, and/or modified silicone material.

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26. (Previously presented) A method for fabricating a microelectronic device, comprising:

providing a microelectronic workpiece having an active side and a backside, the microelectronic workpiece having a plurality of dies at the active side, the dies including integrated circuitry and bond-pads coupled to the integrated circuitry;

fabricating a redistribution layer before separating the dies from each other, the redistribution layer having a dielectric layer over the dies, ball-pads arranged in ball-pad arrays corresponding to the dies, and traces coupling the bond-pads of a die to the ball-pads of a corresponding ball-pad array;

covering the backside of the workpiece with a protective material in a flowable state before separating the dies from each other; and

curing the protective material to create a protective layer on the backside of the workpiece.

- 27. (Original) The method of claim 26, further comprising: attaching a plurality of solder balls to the ball-pads; and covering the dielectric layer with a protective film that surrounds at least a portion of the solder balls.
- 28. (Original) The method of claim 26 wherein covering the backside of the workpiece comprises stencil printing the material onto the backside of the workpiece.
- 29. (Original) The method of claim 26 wherein covering the backside of the workpiece comprises spraying the material onto the backside of the workpiece.
- 30. (Original) The method of claim 26 wherein covering the backside of the workpiece comprises spin coating the material onto the backside of the workpiece.
- 31. (Original) The method of claim 26 wherein covering the backside of the workpiece comprises applying the material onto the backside of the workpiece in a dip bath.

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32. (Original) The method of claim 26 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 50°C to 500°C for

approximately 15-150 minutes.

33. (Original) The method of claim 26 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 150°C to 250°C for

approximately 15-120 minutes.

34. (Original) The method of claim 26 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 150°C for approximately 120

minutes.

35. (Original) The method of claim 26 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 200°C for approximately 15

minutes.

36. (Original) The method of claim 26 wherein curing the material comprises heating

the material in an environment at a temperature of approximately 250°C for approximately 60

minutes.

37. (Original) The method of claim 26 wherein curing the material comprises

changing the material from a flowable state to a non-flowable state using rapid thermal

processing.

38. (Original) The method of claim 26 wherein the material is a polyimide, epoxy-

based, and/or modified silicone material.

39-69. (Cancelled)

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